

McDonnell Boehnen Hulbert & Berghoff Law Offices

Fax transmittal

To

Examiner Ahmed

Company

U.S.P.T.O.

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Re

Pages, with cover 22

August 24, 2001 Date

Amir N. Penn From

312 913 2128

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62/32 C/M

U.S. Patent Application No. 09/022,834

"Method for Removing Organic Contaminants from

a Semiconductor Surface"

MBHB Docket Number: 98,162

FAX RECEIVED

AUG 2 4 2001

GROUP 1700

OF FIGURE

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE (Case No. 98,162)

In re Application of:	
DeGendt, et al.	Garage And Marie 1706
Serial No.: 09/022,834)	Group Art Unit: 1746
)	Examiner: Ahmed
Filed: February 13, 1998	
For: METHOD FOR REMOVING ORGANIC) CONTAMINANTS FROM A	FAXPECENE
A SEMICONDUCTOR SURFACE)	AUG
Commissioner of Patents	GROUP TO
Washington, D.C. 20231	1700

TRANSMITTAL LETTER

Dear Sir:

- In regard to the above-identified Application, we are transmitting herewith the attached 1. as well as any documents referenced therein as being attached or enclosed:
 - Preliminary Amendment (a)
 - Return Receipt Postcard. (b)
- 2. With respect to fees:
 - No fee is required. (a)
 - Please charge any underpayment or credit any overpayment to our Deposit (b) Account, No. 13-2490.
- CERTIFICATE OF MAILING UNDER 37 CFR § 1.8: The undersigned hereby certifies that this Transmittal Letter and the paper, as described in paragraph 1 hereinabove, are being facsimile transmitted to the Patent and Trademark Office (Fax No. (703) 305-7719) on this 24th day of August 2001.

DATED: August 24, 2001

Amir N. Penn Registration No. 40,767



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE (Case No. 98,162)

In re Application of:

DeGendt, et al.

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Serial No.: 09/022,834

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A SEMICONDUCTOR SURFACE

Commissioner for Patents Washington, D.C. 20231

PRELIMINARY AMENDMENT

Dear Sir:

In response to the outstanding Office Action mailed March 22, 2001, please enter the following remarks and amendments in the above-referenced patent application.

IN THE CLAIMS

Please amend claims 27, 51 and 60 as follows. A marked up version of the amended claims, to show all the changes, is attached hereto on pages separate from the amendment in accordance with 37 CFR 1.121(c)(1)(ii).

(Thrice Amended) A method for removing organic contaminants from a substrate, the organic-contaminants resulting from a previous lithographic step, the method comprising the steps of:

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